

Notice of References Cited	Application/Control No. 10/599,160		Applicant(s)/Patent Under Reexamination HABETHA ET AL.	
	Examiner Michael Mapa		Art Unit 2617	Page 1 of 1

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*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
*	A	US-2003/0169697	09-2003	Suzuki et al.	370/310
*	B	US-2003/0103487	06-2003	Kim et al.	370/350
*	C	US-2003/0012176	01-2003	Kondylis et al.	370/348
*	D	US-2003/0214967	11-2003	Heberling, Allen D.	370/437
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	I	US-			
	J	US-			
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FOREIGN PATENT DOCUMENTS

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NON-PATENT DOCUMENTS

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